



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date December 4, 2002

In re the Application of

Hiroji AGA

Group Art Unit: 2823

Application No.: 09/857,803

Examiner: M. Estrada

Filed: June 11, 2001

Docket No.: 109725

For: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 28, 2002, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 136870 in the amount of \$110 in payment for:

X Extension fee for response within first month pursuant to §1.136(a) (\$110.00)  
\_\_\_\_\_ Extension fee for response within second month pursuant to §1.136(a) (\$400.00)  
\_\_\_\_\_ Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

William P. Berridge  
Registration No. 30,024

Stephen Tu  
Registration No. 52,304

JAO:SXT/amw

**OLIFF & BERRIDGE, PLC**  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461

RECEIVED  
DEC - 6 2002  
TECHNOLOGY CENTER 2800